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Contents

vii *Conference Committee*

DESIGN, DEVELOPMENT, AND FABRICATION OF PHOTONIC INSTRUMENTS I

- 12428 02 **Fully automated inverse design solution for metalenses/metasurfaces (Invited Paper)** [12428-1]
- 12428 03 **Design and analysis of the light field camera for SurfCam** [12428-2]
- 12428 04 **Development and evaluation of a photonics instrument for precise beam profile measurements by a XY-stage** [12428-3]
- 12428 05 **Switchable pattern illuminator via liquid crystal geometric phase microlens array** [12428-4]

DESIGN, DEVELOPMENT, AND FABRICATION OF PHOTONIC INSTRUMENTS II

- 12428 06 **Curved CMOS image sensors for enhanced imaging systems: focus on smartphone camera lens** [12428-8]
- 12428 07 **Optical simulation supported development of a dual channel photoelectric smoke detector** [12428-9]

METROLOGY, CHARACTERIZATION, AND FABRICATION OF PHOTONIC INSTRUMENTS I

- 12428 08 **A high-sensitivity, quantitative method to detect micro-scale optics' internal defects and impurity** [12428-10]
- 12428 09 **Imaging system for leak detection using collimated white/color LED light** [12428-11]
- 12428 0A **An upgradable testing platform designed to characterize and test optical components of FMCW LiDARs, particularly optical phased arrays** [12428-12]
- 12428 0B **Photonic Doppler velocimetry with 62.5 μm graded index multimode fiber at 1550 and 532 nm** [12428-13]
- 12428 0C **Polarization-based, transmissive-reflective beam scanner operating around 1550 nm using off-the-shelf components** [12428-14]

DESIGN, DEVELOPMENT, AND FABRICATION OF PHOTONIC INSTRUMENTS III

- 12428 OD **Accuracy evaluation of a new 3D photogrammetric position measurement system for 6D printing** [12428-15]
- 12428 OE **Optomechanical system for photonic chip characterization** [12428-16]
- 12428 OF **High-sensitivity hyperspectral Fourier-plane microscopy by an innovative common-path interferometer** [12428-18]
- 12428 OG **Intermediate image free computed tomography imaging spectrometer** [12428-20]

APPLICATIONS OF PHOTONIC INSTRUMENTS I

- 12428 OH **Multi-color ellipsometric mapping tool from cheap parts** [12428-24]

APPLICATIONS OF PHOTONIC INSTRUMENTS II

- 12428 OI **Machine-learning-enhanced phase-based multi-tone continuous-wave lidar** [12428-26]
- 12428 OJ **Enhancing detecting ammonia from 1 to 10,000's PPM using laser-induced fluorescence of tuned vapochromic coordination polymers** [12428-28]
- 12428 OK **Mid-infrared broadband sensing and temperature dependence of trace gas molecular transitions** [12428-29]

SENSORS AND RUGGEDIZED SYSTEMS I

- 12428 OL **Highly sensitive and rugged gas optical detection via interferometric cavity-assisted photothermal spectroscopy** [12428-30]
- 12428 OM **Non-invasive continuous hypoxia assessment in intra-partum fetus through long wavelength near infrared spectroscopy** [12428-31]
- 12428 ON **Mid-IR photothermal sensing of liquids for trace analysis** [12428-32]
- 12428 OP **Energy harvesting over a fiber-optic distributed acoustic sensor** [12428-34]

METROLOGY, CHARACTERIZATION, AND FABRICATION OF PHOTONIC INSTRUMENTS II

- 12428 0Q Virtual metrology scheme for predictive plasma uniformity diagnosis of plasma-enhanced atomic layer deposition process using optical emission spectroscopy [12428-35]
- 12428 0R Characterization and digital aberration correction of a hyperspectral imaging system for plant disease detection [12428-36]
- 12428 0S Nanostructures for in-situ surface-enhanced Kretschmann-Raether ellipsometry [12428-37]

METROLOGY, CHARACTERIZATION, AND FABRICATION OF PHOTONIC INSTRUMENTS III

- 12428 0T Effect of a q-plate placed behind the objective lens in an imaging camera [12428-39]
- 12428 0U New wafer shape measurement technique for 300mm blank vertically held silicon wafer [12428-42]
- 12428 0V NASA SAGE SBIR structural, thermal, optical performance (STOP) analysis correlation to wavefront error testing [12428-43]

SENSORS AND RUGGEDIZED SYSTEMS II

- 12428 0W QEPAS spectroscopy with fully tunable IC-ECDL with high bandwidth for the MIR range [12428-45]

APPLICATIONS OF PHOTONIC INSTRUMENTS III

- 12428 0X Optimizing of laser source parameters for FMCW automotive LiDARs [12428-50]
- 12428 0Y Enantiomeric excess determination by quantum cascade laser vibrational circular dichroism: a chemometric approach [12428-52]
- 12428 0Z Multi-axis applications of a cryogenic range-resolved laser interferometer [12428-53]

POSTERS SESSION

- 12428 10 On-site spectroscopy as a tool for monitoring phytoremediation by ferns of arsenic contaminated water [12428-55]
- 12428 11 An innovative approach based on hyperspectral imaging for an automatic characterization of post-earthquake building waste [12428-56]

- 12428 12 **Direct defocus measurement using single astigmatic lens: a theoretical study** [12428-58]
- 12428 13 **A novel platform for high-speed, high-resolution LIBS imaging** [12428-59]
- 12428 14 **Non-contact surface profiling using optical interferometric microscopy** [12428-60]
- 12428 15 **Aircraft and cloud detection software for autonomous observation system operation** [12428-61]

DIGITAL POSTER SESSION

- 12428 16 **Camera optics in the ultraviolet region of the Next Generation Palomar Spectrograph**
[12428-62]